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PATENT APPLICATION

ATTORNEY DOCKET NO. 200316546-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Randy Hoffman et al

Confirmation No.: 8519

Application No.: 10/799839

Examiner: Unassigned

Filing Date: Mar 12, 2004

Group Art Unit:

Title: Semiconductor Device

Mail Stop Amendment  
Commissioner For Patents  
PO Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

This Information Disclosure Statement is submitted:

- ☒ under 37 CFR 1.97 (b), or  
(Within three months of filing national application; or date of entry of national application; or before mailing date of first action on the merits; whichever occurs last)
- ☐ under 37 CFR 1.97 (c), together with either a:  
☐ Statement under 37 CFR 1.97 (e), or  
☐ a \$180 fee under 37 CFR 1.17 (p), or  
(After the CFR 1.97 (b) time period, but before final action or notice of allowance, whichever occurs first)
- ☐ under 37 CFR 1.97 (d), together with either a:  
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Applicant(s) submit herewith form PTO 1449 - Information Disclosure Statement together with any required copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

- ☐ A concise explanation of the relevance of foreign language patents, foreign language publications and other foreign language information listed on PTO Form 1449, as presently understood by the individual(s) designated in 37 CFR 1.56 (c) most knowledgeable about the content is given on the attached sheet, or where a foreign language patent is cited in a search report or other action by a foreign patent office in a counterpart foreign application, an english language version of the search report or action which indicates the degree of relevance found by the foreign office is listed on form PTO 1449 and is enclosed.

It is requested that the information disclosed herein be made of record in this application.

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Respectfully submitted,

Randy Hoffman et al

By

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Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>		<b>Complete if Known</b>	
		Application Number	10/799839
		Filing Date	Mar 12, 2004
		First Named Inventor	Randy Hoffman
		Art Unit	
		Examiner Name	Unassigned
Sheet 2	of 2	Attorney Docket Number	200316546-1

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		Proceedings of the IEEE, Proceedings Letters, November 1968, pgs 2094-2095.	
		Extended abstracts of the 2000 International Conference on Solid State Devices and Materials; Aug 29-31, 2000, Sendai Intl Center, pgs 128-129.	
		OHTOMO, "Novel Semiconductor Technologies of ZnO Films towards...", IEICE Trans. Electron., Vol E83-C, No 10, Oct 2000, pgs 1614-1617.	

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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